F INFORMATION DISCLOSURE STATEMENT Docket No. 🗓 nder 37 CFR 1.97(b) or 1.97(c)) OKI.227 Norio HIRASHITA Group Art Unit Filing Date Examiner Serial No. TO BE ASSIGNED TO BE ASSIGNED **APRIL 5, 2001** NEW Title: A STRUCTURE OF A FIELD EFFECT TRANSISTOR HAVING A METALLIC SILICIDE AND MANUFACTURING METHOD THEREOF Address to: **Assistant Commissioner for Patents** Washington, D.C. 20231 37 CFR 1.97(b) The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application; within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or before the mailing date of a first Office Action on the merits, whichever event occurs last. 37 CFR 1.97(c) The Information Disclosure Statement submitted herewith is being filed after three months of the filing of a national application, or the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or after the mailing date of a first Office Action on the merits, whichever occurred last but before the mailing date of either: a Final Action under 37 CFR 1.113, or 1. 2. a Notice of Allowance under 37 CFR 1.311, whichever occurs first. Also submitted herewith is: a certification as specified in 37 CFR 1.97(e); OR the fee set forth in 37 CFR 1.17(p) for submission of an Information Disclosure Statement under 37 CFR 1.97(c).

OF INFORMATION DISCLOSURE STATEMENT Docket No. (Under 37 CFR 1.97(b) or 1.97(c)) OKI.227 e Application Norio HIRASHITA BADEMA Serial No. Filing Date Examiner Group Art Unit TO BE ASSIGNED NEW **APRIL 5, 2001** TO BE ASSIGNED Title: A STRUCTURE OF A FIELD EFFECT TRANSISTOR HAVING A METALLIC SILICIDE AND MANUFACTURING METHOD THEREOF Payment of Fee (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p)) A check in the amount of is attached. The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. as described below. A duplicate copy of this sheet is enclosed. Charge the amount of Credit any overpayment. Charge any additional fee required. Certificate of Transmission by Facsimile* Certificate of Mailing by First Class Mail certify that this document and fee is being deposited certify that this document and authorization to charge with the U.S. Postal Service as deposit account is being facsimile transmitted to the United first class mail under 37 C.F.R. 1.8 and is addressed to the States Patent and Trademark Office (Fax. No. Assistant Commissioner for Patents, Washington, D.C.) on 20231. (Date) Signature Signature of Person Mailing Correspondence

*This certificate may only be used if paying by deposit account.

Signature

Typed or Printed Name of Person Mailing Correspondence

Dated: APRIL 5, 2001

ADAM C. VOLENTINE REG. NO. 33289

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cc:

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INFORMATION DISCLOSURE CITATION			Applicant(s) Norio HIRASHITA et al.	1
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PADE	ARE	Deep sub-0.1 um MOSFET's with Very Thin SOL Layer for Ultra-Low Power Applicants, Information and Communication Engineers C-II Vol. J81-C-II No. 3, pp. 313-319; مانوية الإدامة المرابعة الإدامة المرابعة الإدامة المرابعة		
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	Optimization of Series Resistance in Sub-0.2 um SOI MOSFET's, IEEE Electron Device letters, VOL. 15, No 1994, p. 363-365.			e letters, VOL. 15, No. 9, September
	В	1554, p. 565 565.		
		Optimization of series resistance in Sub-0.2 um SOI MOSFET's, 1993 IEEE, pp. IEDM93-723-726-IEDM 93.		
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not considered. Include copy of this form with next communication to applicant.